

# WEST Search History

09/768, 356

DATE: Monday, April 15, 2002

**Set Name Query**  
side by side

**Hit Count Set Name**  
result set

DB=USPT,PGPB,JPAB,EPAB,DWPI,TDBD; PLUR=YES; OP=ADJ

L68	l18 and (l21 or l22 or l23 or l24 or l25 or l26)	11	L68
L67	l65 and l18	3	L67
L66	L65 and l17	0	L66
L65	L64 and l59	53	L65
L64	l10 and l58	157	L64
L63	l61 and (l4 or l7)	3	L63
L62	L61 and (l5 or l6)	0	L62
L61	(L59 and l58) and (image near2 shift\$3)	22	L61
L60	(L59 and l58) and l56	1	L60
L59	250/397	1166	L59
L58	250/310	1949	L58
L57	L56 and l12	3	L57
L56	l1 and l11	18	L56
L55	l17 and octopole	0	L55
L54	L53 and (image near2 shift\$3)	3	L54
L53	l1 and l52	8	L53
L52	l7 and octopole	129	L52
L51	L48 and (l21 or l22 or l23 or l24 or l25 or l26)	1	L51
L50	L48 and l29	2	L50
L49	L48 and (l13 or l15)	1	L49
L48	l1 and l2	7	L48
L47	L46 and (l13 or l15)	1	L47
L46	L45 and (l21 or l22 or l23 or l24 or l25 or l26)	7	L46
L45	L44 and l21	7	L45
L44	l35 and l10	69	L44
L43	l32 and (l13 or l15)	0	L43
L42	l35 and l32	0	L42
L41	l37 and l29	1	L41
L40	L37 and l34	0	L40
L39	L37 and (l13 or l15)	1	L39
L38	L37 and l12	1	L38

L37	L36 and (l6 or l7)	17	L37
L36	L35 and (l4 or l5)	25	L36
L35	l1 and (l2 or l3)	492	L35
L34	((electric or electrostatic) near2 correct\$3) same ((off-axis or oblique) adj (deviat\$3 or aberrat\$3)))	1	L34
L33	(dual near2 deflect\$3) same ((upper adj stage) with (lower adj stage))	0	L33
L32	(two near2 deflect\$3) same ((upper adj stage) with (lower adj stage))	4	L32
L31	(image adj shifting adj deflector)	2	L31
L30	(image adj shifting adj deflector) near2 system	2	L30
L29	(height near2 measur\$3) same (specimen or sample or holder or target or object)	3213	L29
L28	(height neare measur\$3) same (specimen or sample or holder or target or object)	0	L28
L27	(image adj shifting adj deflector) same (electrostatic or electric)	2	L27
L26	(convert\$3 near2 electrode) same ((wien or energy) adj filter)	1	L26
L25	(conversion near2 electrode) same ((wien or energy) adj filter)	1	L25
L24	(conversion near2 electrode) same (secondary near2 (electron or particle))	35	L24
L23	(convert\$3 near2 electrode) with (secondary near2 (electron or particle))	21	L23
L22	(conversion near2 electrode) with (secondary near2 (electron or particle))	32	L22
L21	((objective adj2 lens)with (specimen or sample or holder or target or object)) same (retard\$3 near2 field)	41	L21
L20	(wien adj filter) with ((off-axis or oblique) adj (deviat\$3 or aberrat\$3))	1	L20
L19	detect\$3 with ((secondary or reflect\$3) near2 (electron or particle or signal))	21425	L19
L18	shield\$3 near3 electrode	12374	L18
L17	(insulat\$3 near2 (disc or disk))with (conduct\$3 near2 (coating or layer))	101	L17
L16	(octopole near3 deflect\$3) same (insulat\$3 near2 (disc or disk))	0	L16
L15	((suppres\$4 or eliminat\$3) with ((off-axis or oblique) adj (deviat\$3 or aberrat\$3)))	23	L15
L14	((electric or electrostatic) adj field) same ((suppres\$4 or eliminat\$3) with (oblique adj (deviat\$3 or aberrat\$3)))	0	L14
L13	((electric or electrostatic) adj field) same ((suppres\$4 or eliminat\$3) with (off-axis adj (deviat\$3 or aberrat\$3)))	1	L13
L12	L10 near4 (specimen or sample or holder or target or object)	143	L12
L11	L10 with (close or "near" or "adjacent")	155	L11
L10	electrostatic near2 (deflect\$3 or octopole)	3624	L10

L9	object\$3 near3 lens	81327	L9
L8	(lower near2 deflect\$3)with octopole	0	L8
L7	lower near2 deflect\$3	5748	L7
L6	(lower adj stage) with deflect\$3	84	L6
L5	(upper adj stage) with deflect\$3	56	L5
L4	upper near2 deflect\$3	5622	L4
L3	scan\$4 near2 deflect\$3	11779	L3
L2	(imag\$3 adj shift\$3) near2 deflect\$3	21	L2
L1	scan\$4 near2 (electron adj microscope)	18166	L1

END OF SEARCH HISTORY